

COLLABORATIVE SEARCH PILOT PROGRAM

BETWEEN KIPO AND THE USPTO

Meeting of the IP5 Heads of Office and the IP5 Industry

June 1, 2016

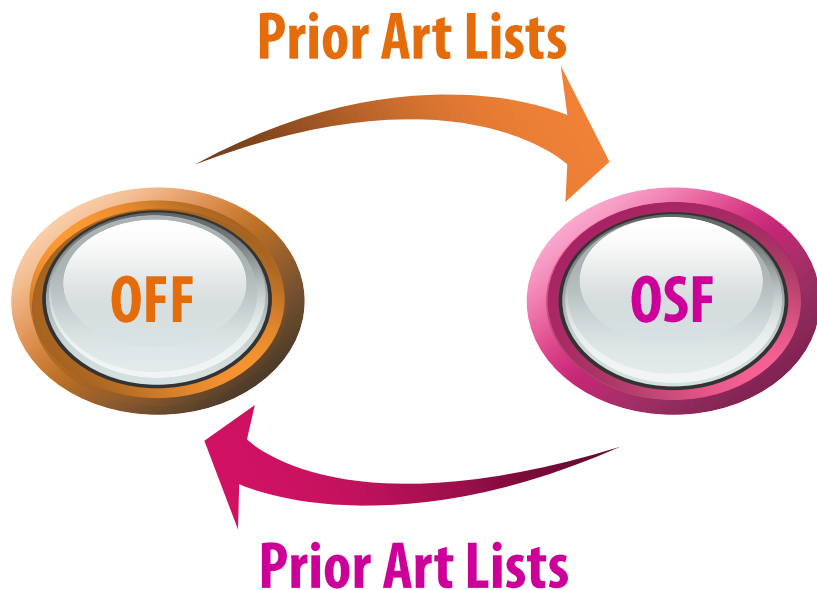
Tokyo



Korean Intellectual Property Office

I. Concept

- ❖ **Sharing the lists of prior art with collaborating office(s) before the first office actions of each office**



- To improve the **quality and consistency** by sharing the lists of prior art timely
- To utilize the **search results of the other office**, which is conducted mainly in the native language and prior art database of each office

II. Benefits to users

01 SPEED → Getting patent “faster”

- By means of expedited or accelerated examination

02 STABILITY → Holding “stronger” patent

- By strengthening the screening process through search results exchange before the first office actions

03 COST → Saving Money

- No administrative fee is needed for the CSP request
- In some cases, applicant could be exempted from paying the fee(s) for requesting expedited examination

III. Status update

Oct. 2014

Concept was proposed by KIPO
(WG3 Meeting)

May 2015

The MOU was signed between KIPO and USPTO
(Suzhou, China)

Sep. 2015

The 'KORUS CSP' has been launched

- *KIPO has been holding the irregular CSP information sessions for the users, mainly upon the request from large law firms as well as candidate applicants/companies having interests in this program*

❖ Examination Status | as of 18 May 2016

51 petitions received

Search Reports in 24 petitions exchanged

First Actions in 21 petitions implemented

* Average Pendency of FA from the petition date: **6.1 months**

❖ Areas of Electricity (21) & Physics (14) are dominant and area of Mechanical Engineering (8) is emerging

H(electricity) 21

H01L(semiconductor devices) 11, H01J(electric discharge tubes) 1, H04N(pictorial communication) 3, H05H(plasma techniques) 2, H02K(dynamo-electric machines) 1, H02J(generation, conversion of electric power) 1, H02P(control of electric motors) 1, H04L(transmission for digital information) 1

G(physics) 14

G06F(electric digital data processing) 7, G11C(static stores) 2, G01C(measuring distances, level 1, G09G(arrangements) 1, G02F(devices the optical operation) 2, G06K(recognition of data) 1, G01N(investigating or analyzing materials) 1

F(mechanical engineering) 8

F16H(gearing) 7, F01p(cooling of machine) 1

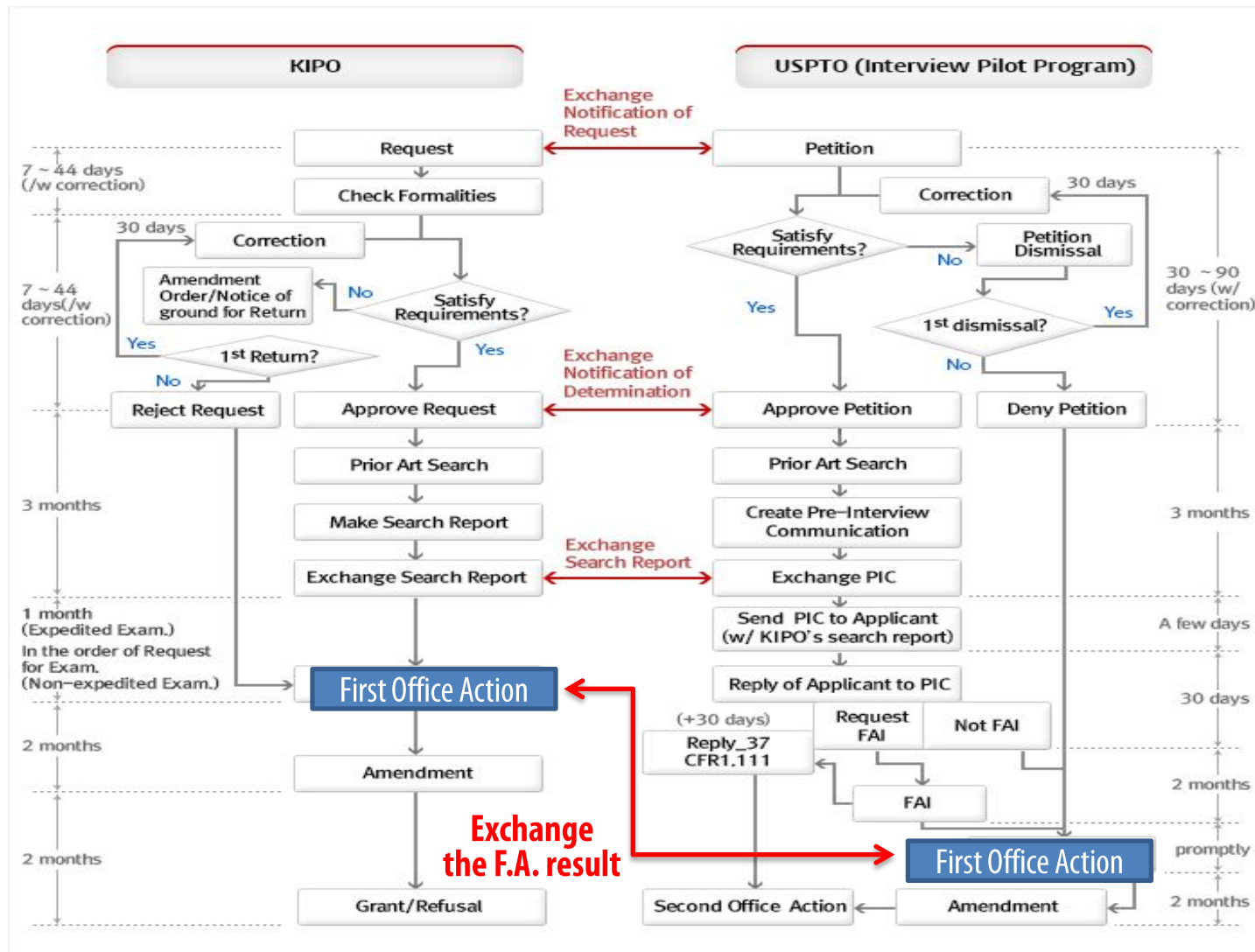
A(human necessities) 6

A61B(diagnosis, surgery, identification) 6

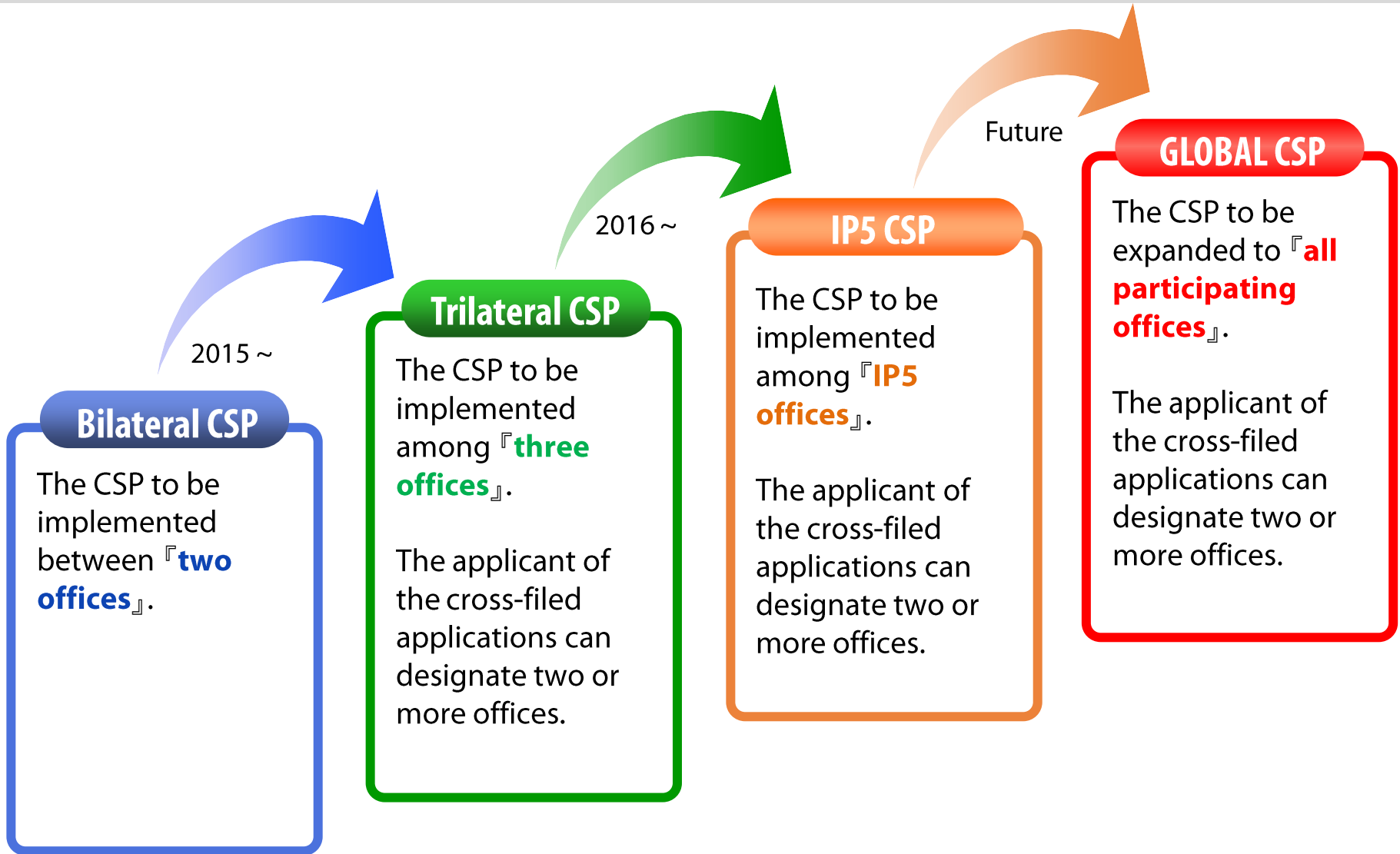
B(performing operations) 2

B60K(arrangement of propulsion units) 1, B60L(Electric Equipment of Vehicles) 1

IV. Procedure improvement plan



V. Roadmap of CSP



❖ A portal site for the CSP would be opened, if necessary

Thank you!

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